

IN THE U.S. PATENT AND TRADEMARK OFFICE

INFORMATION SHEET

Applicant: FUJIMURA, Shigeto
ASAHI, Toshiaki
SATO, Kenji

Application No.:

Filed: January 4, 2001

For: PROCESS FOR PRODUCING COMPOUND SEMICONDUCTOR SINGLE CRYSTAL

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
JAPAN	01/07/00	2000-1675

Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP
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The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

MARC S. WEINER

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